

Notice of References Cited	Application/Control No. 10/676,896	Applicant(s)/Patent Under Reexamination HO ET AL.	
	Examiner Chandra Chaudhari	Art Unit 2813	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,937,295	08-1999	Chen et al.	438/261
	B	US-6,165,842	12-2000	Shin et al.	438/962
	C	US-6,690,059	02-2004	Lojek, Bohumil	257/316
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ghandhi, "VLSI Fabrication Principles", 1983, pages 420-424.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.